IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application:)	
In to patent application.	Ś	"Express Mail" label number EV 432598396 US
Hyungsoo Choi) Before the Examiner) (Unknown)	Date of Deposit April 19, 2004
Serial No. New Application)) Group Art Unit	I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR §1.10 on the date indicated above
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ORGANOMETALLIC COMPOUNDS AND THEIR USE AS PRECURSORS FOR FORMING FILMS AND POWDERS OF) Our Ref.: 22010-209	Signature of person mailing paper or fee
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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure embodied in 37 C.F.R. §1.56, Applicants wish to bring to the attention of the Examiner the references listed on the enclosed Information Disclosure Statement. These references have been cited by the International Searching Authority and have not been previously submitted in this application, nor heretofore cited by the examiner. Copies of the cited references are enclosed in accordance with 37 C.F.R. §1.98.

The filing of this Information Disclosure Statement shall not be construed as an admission that the information cited is, or is considered to be, material to the patentability as defined in §1.56(b).

This Statement is being submitted with the filing of the application. It is believed that no fee is required for consideration of the submitted item. Should any fee be required, however,

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Respectfully submitted,

Edward E. Sowers

Reg. No. 36,015

Woodard, Emhardt, Naughton

Moriarty & McNett

Bank one Center/Tower

111 Monument Circle, Suite 3700

Indianapolis, IN 46204-5137

(317) 634-3456

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Substitute	e for form 1449A/	/P10		Application Number	New Application		
INFO	INFORMATION DISCLOSURE			Filing Date	April 19, 2004		
STA	STATEMENT BY APPLICANT		First Named Inventor	Hyungsoo Choi			
				Group Art Unit	Unknown		
(use as many sheets as necessary)		Examiner Name	Unknown				
Sheet	1	of	1	Attornev Docket Number	22010-209		

U.S. PATENT DOCUMENTS								
Examiner Cite Initials* No.1		Document Number Number-Kind Code ² (If known)	Publication Date Name of Patentee or Application of Cited Document		Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear			
		3,088,361	05/07/1963	Lay				
		4,645,849	02/24/1987	Lewis				
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Examiner Cite Initials* No.	Cite	Foreign Patent Document	Publication Date	Name of Patentee or Application of Cited	Pages, Columns, Lines, Where Relevant Passages or Relevant	Τª
		Country Code ⁵ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY	Document	Figures Appear	<u> </u>
		GB 717,269	10/27/1954	Azfa Ag Fuer		
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		WO1999KR0000260	12/02/1999	Ahn, et al.		<u> </u>
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INFORMATION DISCLOSURE			OSURE	Filing Date	April 19, 2004		
STATEMENT BY APPLICANT		First Named Inventor	Hyungsoo Choi				
				Group Art Unit	Unknown		
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Sheet	1	of	2	Attorney Docket Number	22010-209		

	OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	T ²					
		KRUSE, WALTER, ET AL.: "Synthesis and configuration of hydrido(alkyl phosphito)-cobalt and-iron compounds" CHEM. COMMUN., no. 15, 1968, pages 921-922						
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Sheet	2	of	2	Attorney Docket Number	22010-209		

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	_
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	7
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